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(Not for submission under 37 CFR 1.99)

Application Number	10766336
Filing Date	2004-01-28
First Named Inventor	Shyh-Mei Ho
Art Unit	2175
Examiner Name	Stephen D. Alvesteffer
Attorney Docket Number	SVL920030102US1

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	3	6909903	B2	2005-06-21	Wang	
	4	6948117	B2	2005-09-20	Van Eaton et al.	
	5	7000238	B2	2006-02-14	Nadler et al.	
	6	7024413	B2	2006-04-24	Binding et al.	
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9	7054901	B2	2006-05-30	Shafer	
10	7111011	B2	2006-09-19	Graves et al.	
11	7120645	B2	2006-10-10	Manikuliy et al.	
12	7120702	B2	2006-10-10	Huang et al.	
13	7124299	B2	2006-10-17	Dick et al.	
14	7134075	B2	2006-11-07	Hind et al.	
15	7152205	B2	2006-12-19	Day et al.	
16	7266582	B2	2007-09-14	Stelting	
17	7296226	B2	2007-11-13	Junkermann	
18	6816883	B2	2004-11-09	Baumeister et al.	
19	6067579		2000-05-23	Hardman et al.	

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	20	6097688		2000-08-01	Ichimura et al.	
	21	6738975	B1	2004-05-18	Yee et al.	

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	2	20020156930	A1	2002-10-24	Velasquez	
	3	20030191970	A1	2003-10-09	Devine et al.	
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	1	Jouko Jantti et al., "IMS Version 9 Implementation Guide", ibm.com/redbooks, pages 139-143.	<input type="checkbox"/>

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